

Handbook Of Ion Implantation Technology

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Patents Publication number More technical discussion can be found in Handbook of Ion Implantation Technology, J. C. Ziegler, ed.; Elsevier Science Publishers B. V

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Handbook of ion beam processing technology. The where implantation of the incident ion is a minor effect. Of the types of ion sources and devices available,

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Ion implantation is the primary technology which is used in the semiconductor industry to introduce impurities into semiconductors to form devices and VLSI circuits.

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1 Interactions of ion beams with polymers: the physical picture. Alexey Handbook of ion implantation technology, Elsevier (2003) V.B. Odzhaev, I.P

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